



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

3728
Applicant : Andreas Norbert Wiswesser, et al. Art Unit : Unknown
Serial No. : 09/851,661 Examiner : Unknown
Filed : May 8, 2001
Title : METHOD AND APPARATUS FOR DETERMINING SUBSTRATE LAYER THICKNESS DURING CHEMICAL MECHANICAL POLISHING

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed. A copy of a communication from a foreign patent office in a counterpart application is also enclosed.

This statement is being filed before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated December 18, 2002, which is not more than three months prior to the filing of this statement.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 1/23/03

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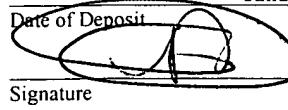
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